

PTO-1449

Application No.

Applicant(s)

10/678,837

Tomblad et al.

**Information Disclosure Citation
in an Application**

Docket Number

Group Art Unit

Filing Date

068736.0231

2811

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U.S. PATENT DOCUMENTS

	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
A.	5132753	7/21/92	Chang et al.	257 357	655 23.4	3/23/90
B.	6613622	9/2/03	Nair et al.	438	188	7/15/02
C.						
D.						
E.						
F.						
G.						
H.						
I.						
J.						
K.						
L.						
M.						
N.						
O.						

FOREIGN PATENT DOCUMENTS

	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
P.							
Q.							
R.							
S.							
T.							
U.							

NON-PATENT DOCUMENTS - DOCUMENT (Including Author, Title, Source, and Pertinent Pages)

V.	Dragon et al., "A Silicon MOS Process for Integrated RF Power Amplifiers," IEEE MTT-S Digest, Pages 257-260	6/17/96
W.		
X.		
Y.		
Z.		

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.